

Electronic Patent Application Fee Transmittal

Application Number:	10549294			
Filing Date:	16-Sep-2005			
Title of Invention:	Material for purification of semiconductor polishing slurry, module for purification of semiconductor polishing slurry and process for producing semiconductor polishing slurry			
First Named Inventor/Applicant Name:	Mitsugu Abe			
Filer:	Marvin Jay Spivak/Genet Tsige			
Attorney Docket Number:	278426US0PCT			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Independent claims in excess of 3	1614	1	200	200
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 2 months with \$0 paid	1252	1	450	450
Miscellaneous:				
Total in USD (\$)				650